

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S398	186	(semiconductor same electrochemical same (depth or profiling)) or (electrochemical near5 capacitance near5 (voltage or potential))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 10:45
S399	4	S398 and ((bubbles or gas or film) near5 (monitor\$3 or detect\$3 or sens\$3))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 10:46
S400	28203	(semiconductor near5 (profiling or analysis or testing))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 10:53
S401	2336	S400 and (electrochemical or capacitance)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 10:54
S402	153	S401 and ((bubbles or gas or film) near5 (monitor\$3 or detect\$3 or sens\$3))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 10:55
S404	197	(S398 or S401) and (bubbles or (surface near1 film))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 11:36
S406	142	("C-V" or (capitance adj voltage)) and bubble	USPAT; EPO; JPO; DERWENT	OR	ON	2009/12/28 13:27
S407	186	(semiconductor same electrochemical same (depth or profiling)) or (electrochemical near5 capacitance near5 (voltage or potential))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:46
S408	17	S407 and ((measur\$3 or determin\$3) near3 area)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:46
S409	28203	(semiconductor near5 (profiling or analysis or testing))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:46
S410	2336	S409 and (electrochemical or capacitance)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:46

S411	150	S410 and ((measur\$3 or determin\$3) near3 area)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:46
S412	165	S408 or S411	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 13:47
S413	35	(electrochemical near3 (depth or profiling)) and (semiconductor or wafer or capacitanc)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 14:51
S414	36	(electrochemical near3 (depth or profiling)) and (semiconductor or wafer or capacitance)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 14:51
S415	5	S414 and ((measur\$3 or determin\$3 or calculat\$3) near3 area)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 14:51
S416	31	S410 and ((calculat\$3) near3 area)	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 14:53
S417	4	S407 and ((measur\$3 or determin\$3 or calculat\$3) near3 (radius or diameter))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 15:09
S418	48	S410 and ((measur\$3 or determin\$3 or calculat\$3) near3 (radius or diameter))	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 15:10
S419	52	S417 or S418	USPAT; EPO; JPO; DERWENT	OR	OFF	2009/12/28 15:10

12/30/2009 10:42:41 AM

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